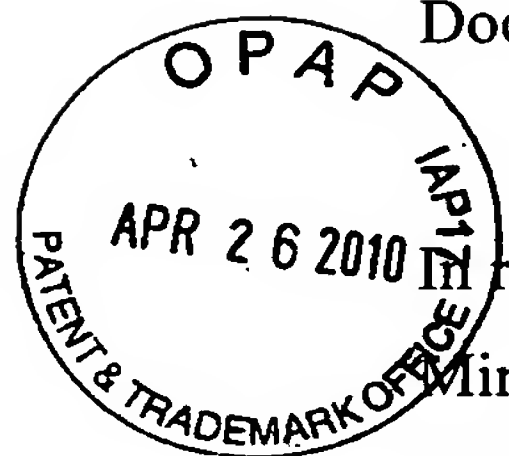


Serial No. 10/569,838
Docket No. F06-436-US

(FUJIT.081)



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Shinjiro HIRAMATSU, et al.

Serial No.: 10/569,838

Group Art Unit: 1792

Filed: December 1, 2006

Examiner: Louie, Mandy C.

For: METHOD FOR PRODUCING CARBON NANOWALLS, CARBON
NANOWALL, AND APPARATUS FOR PRODUCING CARBON
NANOWALLS

Honorable Commissioner of Patents
Alexandria, Virginia 22313-1450

AMENDMENT UNDER 37 C.F.R. § 1.111

AND

STATEMENT OF SUBSTANCE OF THE PERSONAL INTERVIEW

Sir:

In view of the Office Action dated November 25, 2009, please amend the above-identified application as follows:

INTRODUCTORY COMMENTS

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper. No new matter is added.

Remarks begin on page 7 of this paper.